Universida_{de}Vigo

Subject Guide 2017 / 2018

| | | | | | Subject G | Guide 2017 / 2018 |
|--------------|---------------------------------|------------------------------|--------------------|-----------------|------------|-------------------|
| | | | | | | |
| IDENTIFYIN | | | | | | |
| Laser techr | | | | | | |
| Subject | Laser technology | | | | | |
| Code | V12G360V01908 | | | | | |
| Study | Degree in | | | | | |
| programme | Industrial | | | | | |
| | Technologies | | | | | |
| | Engineering | | | | | |
| Descriptors | ECTS Credits | | Choose | Year | C |)uadmester |
| · · · | 6 | | Optional | 4th | 2 | nd |
| Teaching | Spanish | | • | | | |
| language | English | | | | | |
| Department | | | | | | |
| Coordinator | Pou Saracho, Juan María | | | | | |
| Lecturers | Arias González, Felipe | | | | | |
| Lecturers | Lusquiños Rodríguez, Fern | ando | | | | |
| | Pou Saracho, Juan María | ando | | | | |
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| Web | Jpou@uvigo.es | | | | | |
| General | (*)Introduction to laser tec | handow and its application | na far undararadu | isto ctudonte e | f the indu | strial field |
| description | | intology and its application | is for undergradu | | n the muu | sulai nelu. |
| description | | | | | | |
| | - | | | | | |
| Competenc | ies | | | | | |
| Code | | | | | | |
| | G10 Ability to work in a mult | idisciplinary and multiling | ual environment. | | | |
| D10 C | Γ10 Self learning and work. | | | | | |
| | | | | | | |
| Learning ou | itcomes | | | | | |
| | sults from this subject | | | | Trainir | ng and Learning |
| Expected les | suits nom this subject | | | | IIaiiiii | Results |
| - Know the | physical principles in which | it bases the eneration of a | lacor and his nar | +c | | D10 |
| | main properties of a laser ar | | | | B10 | DIO |
| | different types of lasers diffe | | | 115. | | |
| | | | | | | |
| □- Know the | main applications of the tecl | nnology laser in the indust | .ry. | | - | |
| | | | | | | |
| Contents | | | | | | |
| Торіс | | | | | | |
| | NTRODUCTION | 1. Electromagne | tic waves in the v | acuum and in | the matte | r. |
| | | 2. Laser radiation | | | | |
| | | | he laser radiatior | ۱. | | |
| Chapter 2 E | BASICS | | energy level diagr | | | |
| | | | | | | |

| | Spontaneous emission of electromagnetic radiation. |
|----------------------------------|--|
| | 3. Population inversion. |
| | 4. Stimulated emission. |
| | 5. Amplification. |
| Chapter 3. COMPONENTS OF A LASER | 1. Active medium |
| | 2. Excitation mechanisms. |
| | 3. Feedback mechanisms. |
| | 4. Optical cavity. |
| | 5. Exit device. |
| Chapter 4. TYPES OF LASER | 1. Gas lasers |
| | 2. Solid-state lasers |
| | 3. Diode lasers. |
| | 4. Other lasers. |

| Chapter 5. OPTICAL COMPONENTS AND SYSTEMS | Spherical lenses. optical centre of a lens. Thin lenses. Ray tracing. Thin lenses coupling. Mirrors. Filters. OPtical fibers. |
|---|--|
| Chapter 6. INDUSTRIAL APPLICATIONS | Introduction to laser materials processing Introduction to laser cutting and drilling. Introduction to laser welding. Introduction to laser marking. Introduction to laser surface treatments. |

| Planning | | | |
|---|---------------------------|------------------------------|-----------------------------|
| | Class hours | Hours outside the | Total hours |
| | | classroom | |
| Laboratory practises | 18 | 30.6 | 48.6 |
| Master Session | 32.5 | 65 | 97.5 |
| Long answer tests and development | 1.7 | 0 | 1.7 |
| Reports / memories of practice | 1.9 | 0 | 1.9 |
| Short answer tests | 0.3 | 0 | 0.3 |
| *The information in the planning table is for | guidance only and does no | ot take into account the het | erogeneity of the students. |

| Methodologies | |
|----------------------|--|
| | Description |
| Laboratory practises | Activities of application of the knowledge to specific situations and of acquisition of basic and practical skills related to the matter object of study. They will be developped in the laboratories of industrial applications of the lasers of the EEI. |
| Master Session | Exhibition on the part of the teacher of the contents on the matter object of study. Exhibition of real cases of application of the laser technology in the industry. |

| Personalized attention | | | |
|------------------------|-------------|--|--|
| Methodologies | Description | | |
| Laboratory practises | | | |

| Assessment | | | | | |
|-----------------------------------|---|---------------|-----|---------------------------|--|
| | Description | Qualification | Lea | ing and rning sults | |
| Long answer tests and development | The examination will consist of five questions of equal value. Four of them will correspond to the contents of theory and the fifth one to the contents seen in the laboratory practices. | 70 | B10 | D10 | |
| Reports / memories of practice | The evaluation of the laboratory practices will be carried out by means of the qualification of the corresponding practice reports. | 20 | B10 | D10 | |
| Short answer tests | During the course there will be carried out a test of follow-up of the subject that will consist of two questions of equal value. | 10 | B10 | D10 | |

Other comments on the Evaluation

If some student was resigning officially the continuous assessment that is carried out by means of the test of follow-up of the subject, the final note would be calculated by the following formula: (0.8 x Exam qualification) + (0.2 x Practices qualification). It is mandatory to carry out the laboratory parctices in order to pass the subject. It is mandatory to attend 75% of the theory lessons to pass the subject.

Ethical commitment: it is expected an adequate ethical behaviour of the student. In case of detecting unethical behaviour (copying, plagiarism, unauthorized use of electronic devices, etc.) shall be deemed that the student does not meet the requirements for passing the subject.

In this case, the overall rating in the current academic year will be Fail (0.0).

The use of any electronic device for the assessment tests is not allowed unless explicitly authorized. The fact of introducing unauthorized electronic device in the

Sources of information Basic Bibliography Jeff Hecht, UNDERSTANDING LASERS: AN ENTRY-LEVEL GUIDE, IEEE, 2008 W.Steen, J. Mazumder, LASER MATERIALS PROCESSING, Springer, 2010 Complementary Bibliography

Recommendations

Other comments

Requirements: To register for this module the student must have passed or be registered for all the modules of the previous year